Docket No.: 01641/0204258-US0

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Karl-Heinz Schuster et al.

Application No.: To be assigned Confirmation No.:

Filed: June 19, 2006 Art Unit:

For: MICROLITHOGRAPHY PROJECTION

OBJECTIVE WITH CRYSTAL LENS

Examiner:

## **PRELIMINARY AMENDMENT**

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## INTRODUCTORY COMMENTS

Please amend the above-identified U.S. patent application as follows:

Amendments to the Specification are reflected on page 2.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.